

2128
EFW



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q62740

Masahiro MAEDA

Appln. No.: 09/765,639

Group Art Unit: 2128

Confirmation No.: 6818

Examiner: Morella I. Rosales Hanner

Filed: January 22, 2001

For: METHOD OF EVALUATING REFLECTION PERFORMANCE OF REFLECTING MIRROR, EVALUATION SYSTEM FOR EVALUATING REFLECTION PERFORMANCE OF REFLECTING MIRROR, AND COMPUTER-READABLE STORAGE MEDIUM STORING PROGRAM FOR

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 3, 2004, please amend the above-identified application as follows on the accompanying pages.

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